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Ajeeta Patil, Toshiyuki Ohashi, Alper Buldum, and Liming Dai

Citation: Appl. Phys. Lett. 89, 103103 (2006); doi: 10.1063/1.2345253
View online: http://dx.doi.org/10.1063/1.2345253
View Table of Contents: http://apl.aip.org/resource/1/APPLAB/v89/i10
Published by the American Institute of Physics.

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Controlled preparation and electron emission properties of three-dimensional micropatterned aligned carbon nanotubes

Ajeeta Patil  
Department of Polymer Engineering, College of Polymer Science and Polymer Engineering, University of Akron, Akron, Ohio 44325

Toshiyuki Ohashi  
Honda Research Institute USA, Inc., 1381 Kinnear Rd., Suite 116, Columbus, Ohio 43212

Alper Buldum  
Department of Physics, College of Arts and Sciences, University of Akron, Akron, Ohio 44325

Liming Dai  
Department of Chemical and Materials Engineering, School of Engineering, University of Dayton, 300 College Park, Dayton, Ohio 45469-0240 and UDRI, University of Dayton, 300 College Park, Dayton, Ohio 45469-0240

(Received 6 May 2006; accepted 24 July 2006; published online 5 September 2006)

The authors have developed a simple, but very effective and versatile, dry contact transfer technique for controlled preparation of three-dimensional (3D) perpendicularly aligned carbon nanotube micropatterns with region-specific tube lengths. The 3D micropatterned aligned carbon nanotubes were demonstrated to show a stepwise electron emission behavior, providing an effective means for developing multifunctional electron emitters with tailor-made field emission characteristics. © 2006 American Institute of Physics. [DOI: 10.1063/1.2345253]

Soon after the discovery of carbon nanotubes by Iijima in 1991, de Heer et al., Rinzler et al., and Saito et al. reported the field emission from carbon nanotubes. Since then, electron emission properties of various carbon nanotubes, either in a patterned or nonpatterned form, have been studied extensively. Of particular interest, electron emissions from vertically aligned carbon nanotubes (ACNTs) with a homogenous tube length, either in a two-dimensionally (2D) micropatterned or nonpatterned form, were reported, along with some peculiar emission features (e.g., the edge effect for patterned carbon nanotube arrays). As a result, carbon nanotubes have been exploited as field emitting materials for display applications. As far as we are aware, however, the electron emission from three-dimensional (3D) ACNT micropatterns has not been discussed in the literature largely because of the lack of an effective method for preparing 3D ACNT micropatterns with a region-specifically controllable tube length.

On the other hand, we, along with others, have devised various micropatterning methods, including photolithography, soft lithography, and contact transfer, for producing 2D ACNT micropatterns. Our further study in patterning of ACNTs by the dry contact transfer method, we found that 3D ACNT micropatterns with a region-specifically controllable tube length can be prepared through the dry contact transfer with slight modification. Here, we report the detailed procedures for the formation of 3D ACNT micropatterns by the modified dry contact transfer method, along with electron emission characteristics of the 3D ACNT micropatterns thus produced.

To demonstrate the 3D ACNT micropatterning, we first synthesized nonpatterned ACNT array with a homogenous tube length on a quartz glass plate by pyrolysis of FePc in Ar/H₂ atmosphere at 1100 °C according to our published procedure. As shown in Fig. 1, the as-synthesized ACNT array was then coated with a micropatterned metal (e.g., Al, Ag, and Au) layer by patterned sputter coating (or thermal evaporation) through a physical mask (e.g., a transmission electron microscopy (TEM) grid, top left of Fig. 1). The thickness of the metal coating was controlled by changing the coating conditions (e.g., deposition time). After a desirable coating thickness was obtained, an adhesive film (e.g., a 3M Scotch tape) was pressed onto the ACNT array patterned with the metal layer (top right of Fig. 1), followed by peeling off the Scotch tape with the ACNT film from the quartz substrate in a dry state and turning over the Scotch-supported ACNT film upside down. Finally, 3D ACNT micropatterns with a region-specific tube length were produced by simply pushing up the Scotch tape underneath the metal-patterned area against the rest part of the ACNT film (bottom right of Fig. 1).

FIG. 1. (Color online) Procedures for the fabrication of 3D ACNT micropatterns.
3D ACNT micropatterns thus prepared were characterized by scanning electron microscopy (SEM). Figures 2(a) and 2(b) reproduce a typical 3D ACNT micropattern prepared by the dry contact transfer using a TEM grid mask with hexagonal windows of a 100 \( \mu \)m width and a 50 \( \mu \)m wide grid bar, which shows layered hexagonal micropatterns. The 3D micropatterned ACNTs are clearly evident by inspection of Figs. 2(a) and 2(b) under higher magnifications [Figs. 2(c) and 2(d)]. Figures 2(c) and 2(d) also show that the tube height difference in the 3D micropatterned ACNTs is ca. 10 \( \mu \)m, in consistent with the thickness of the micropatterned metal layer. The alignment of the transferred carbon nanotubes is largely retained in both of the layered structures.

The interesting electron emitting properties reported for both nonpatterned and 2D micropatterned ACNT arrays\textsuperscript{5–10} prompted us to measure electron emissions from these 3D micropatterned ACNT arrays. To construct the 3D micropatterned ACNTs for electron emission measurements, we prepared a conducting electrode by depositing a thin layer of Au homogenously over the whole nanotube array either before or after the metal patterning (cf. Fig. 1). Electron emitting characteristics of the 3D ACNT micropatterns were then measured using a customer-made setup according to the published procedure,\textsuperscript{28,29} using a spacer with a relatively small window size of about \( 2 \times 2 \) mm\(^2\) to cover the micropatterned emitting area. The electron emitting property of the as-synthesized (nonpatterned) ACNT array was also measured as reference. The obtained I–E plots for the as-synthesized and 3D micropatterned ACNTs are given in Fig. 3. As can be seen in Fig. 3, the emission behavior of the 3D micropatterned ACNTs shows a deviation from its nonpatterned counterpart [Fig. 3(a)].

The silent feature to note is that the I–E curve for the 3D micropatterned ACNTs shows a stepwise emission with two possible turn-on voltages. The second turn-on voltage coincides with that observed in the case of nonpatterned ACNT (i.e., 1.6 V/\( \mu \)m). The lower turn-on voltage observed in Fig. 3(b) is, most probably, attributed to the elevated ACNTs, which is, most probably, resulted from the elevated ACNTs from its nonpatterned counterpart, but under higher magnifications. Scale bars: (a) 200 \( \mu \)m, (b) 100 \( \mu \)m, (c) 50 \( \mu \)m, and (d) 20 \( \mu \)m.

FIG. 2. [(a) and (b)] SEM micrographs of the 3D ACNT micropattern prepared by the modified dry contact transfer technique and [(c) and (d)] the same as for (a) and (b), but under higher magnifications. Scale bars: (a) 200 \( \mu \)m, (b) 100 \( \mu \)m, (c) 50 \( \mu \)m, and (d) 20 \( \mu \)m.

In view of the above peculiar emission behavior of the 3D micropatterned ACNTs and our earlier results of a field-enhanced emission current and reduced turn-on voltage for electron emitters based on nonpatterned plasma-polymer-coated ACNT arrays,\textsuperscript{28,29} we moved one step further in this study to test if the stepwise emission seen above could also be introduced by patterned plasma modification of the ACNT emitters while retaining their uniform height. The plasma patterned ACNT array was performed on an as-synthesized FePc-generated ACNT array by plasma polymerization of hexane with the monomer pressure of 0.25 Torr at 250 kHz and 30 W for 90 s through the hexagonal TEM grid.\textsuperscript{30} For comparison, an ACNT array was also treated by hexane-plasma polymerization under the same condition, but without using the TEM grid for patterning.

Figures 4(a) and 4(c) show changes in the I–E curves for the nonpatterned ACNT array upon plasma polymerization of hexane. In consistent with our previous results,\textsuperscript{28,29} the hexane-plasma coating reduced the turn-on electric field from ca. 1.6 to ca. 1.0 V/mm, coupled with a concomitant increase in the emission current at a constant \( E \) due to an enhanced field at the nanotube tips while insulating their wall with the nonconducting plasma polymer coating. Like the 3D micropatterned ACNTs, the I–E curve for the plasma-patterned ACNT array in Fig. 4(b) shows a stepwise emission with two possible turn-on voltages. This behavior can be attributed to sequential electron emissions from the plasma-polymer-coated ACNTs and pure ACNTs within the same plasma-patterned ACNT array. In this particular case, the plasma-coated ACNTs started emitting electrons at the first turn-on voltage of ca. 1.4 V/\( \mu \)m, followed by the field emission from the pure ACNTs turned on at ca. 1.7 V/\( \mu \)m, leading to a stepwise jump in the I–E curve [Fig. 4(b)], cf. Fig. 3.
3(b)]. Therefore, the above observed stepwise emissions are rather general for multicomponent electron emitters.

In summary, we have developed a simple, but very effective and versatile, dry transfer technique for controlled preparation of 3D perpendicularly aligned carbon nanotube micropatterns with region-specific tube lengths. We have further used the 3D micropatterned aligned carbon nanotubes as electron emitters. We found a stepwise electron emission behavior for the 3D micropatterned aligned carbon nanotubes and their 2D counterparts prepared by plasma patterning. The observed stepwise electron emission was demonstrated to be rather versatile for multicomponent emitters, providing an effective means for developing multifunctional electron emitters with tailor-made field emission behaviors. With the recent rapid development in nanoscience and nanotechnology, these 3D micropatterned and plasma-patterned aligned carbon nanotube electron emitters reported in this study could be very useful in many multidimensional and multifunctional systems, including patterned electron emitting displays, multianalyte sensors, multichannel microreactors, and microfluidic devices.

The authors thank Honda R&D, Co., Ltd. and AFOSR (FA9550-06-1-0384) for financial support.